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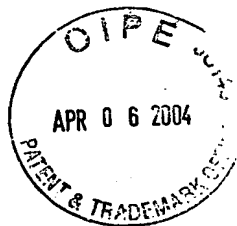
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1/24

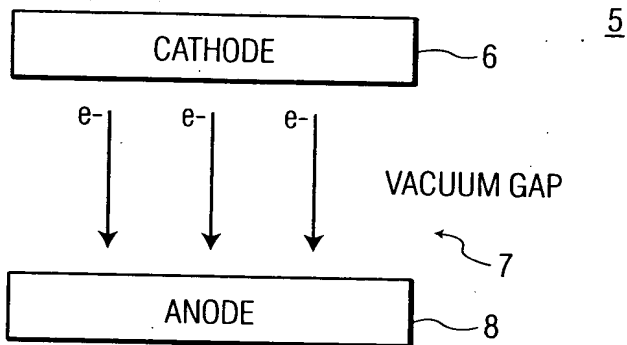


FIG. 1

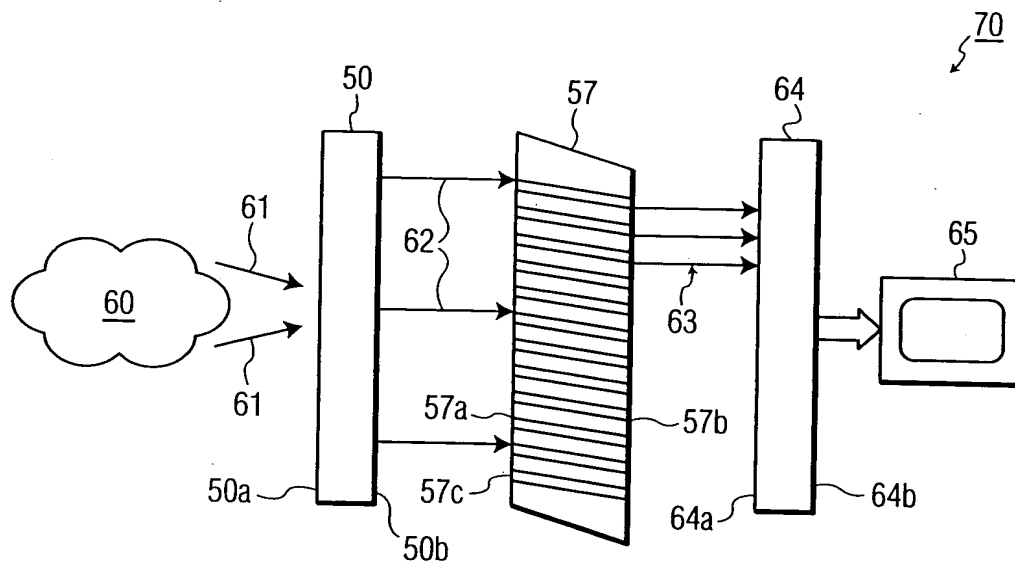


FIG. 2

2/24

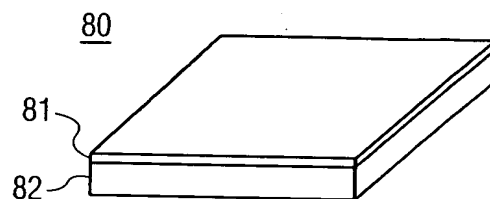


FIG. 3A

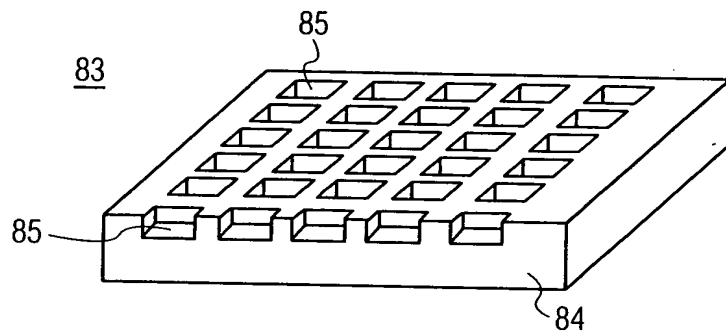


FIG. 3B

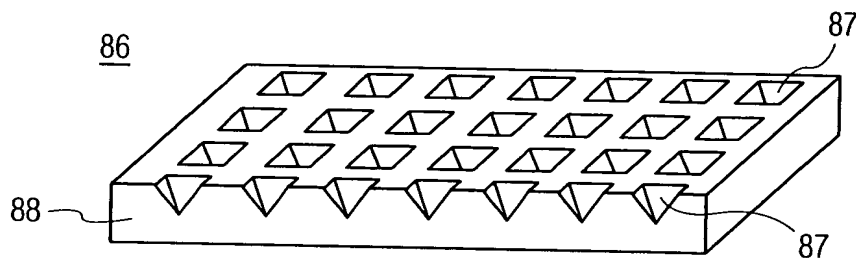


FIG. 3C

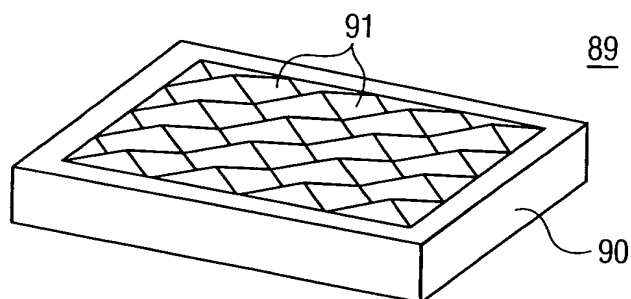


FIG. 3D

3/24

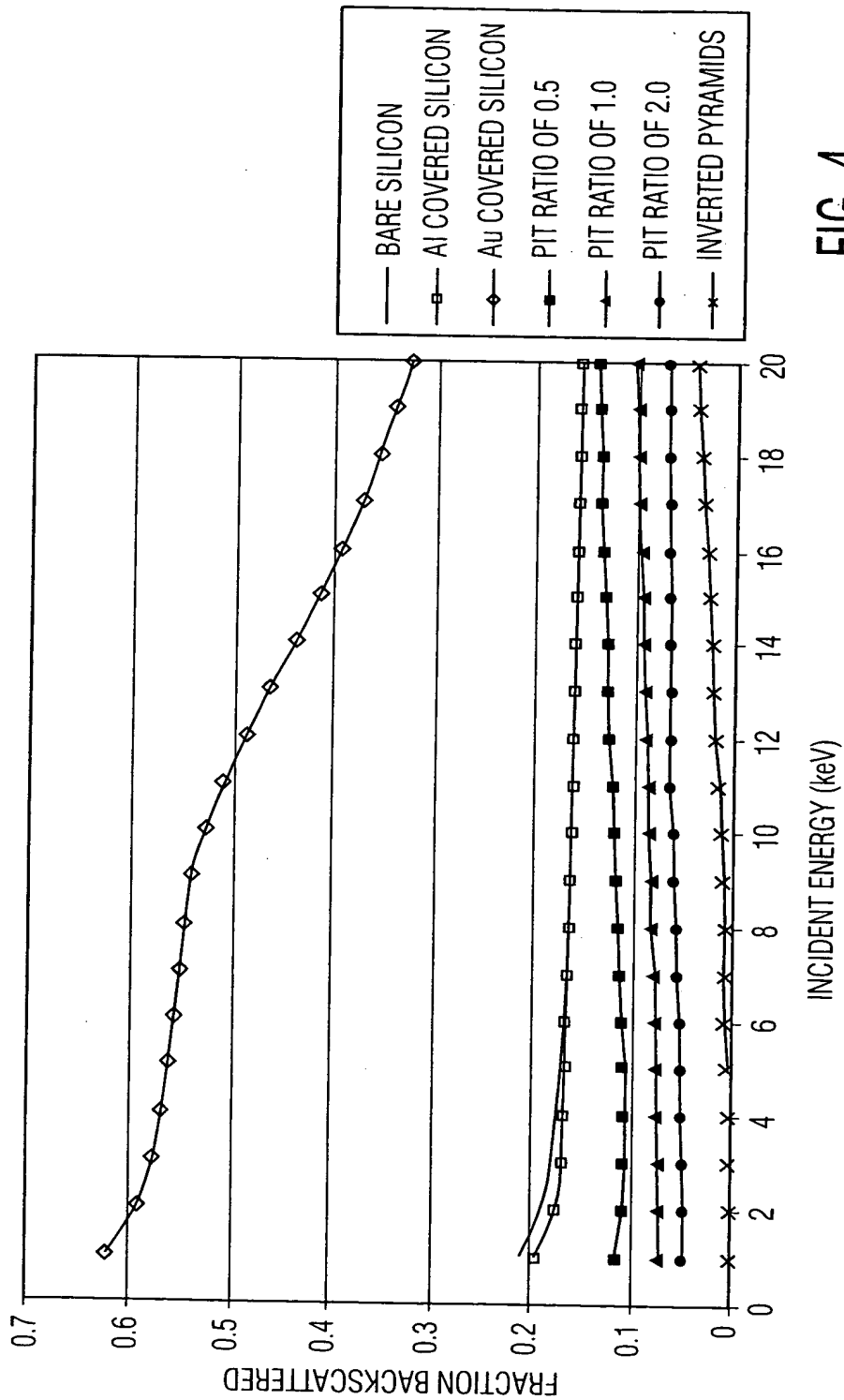


FIG. 4

4/24

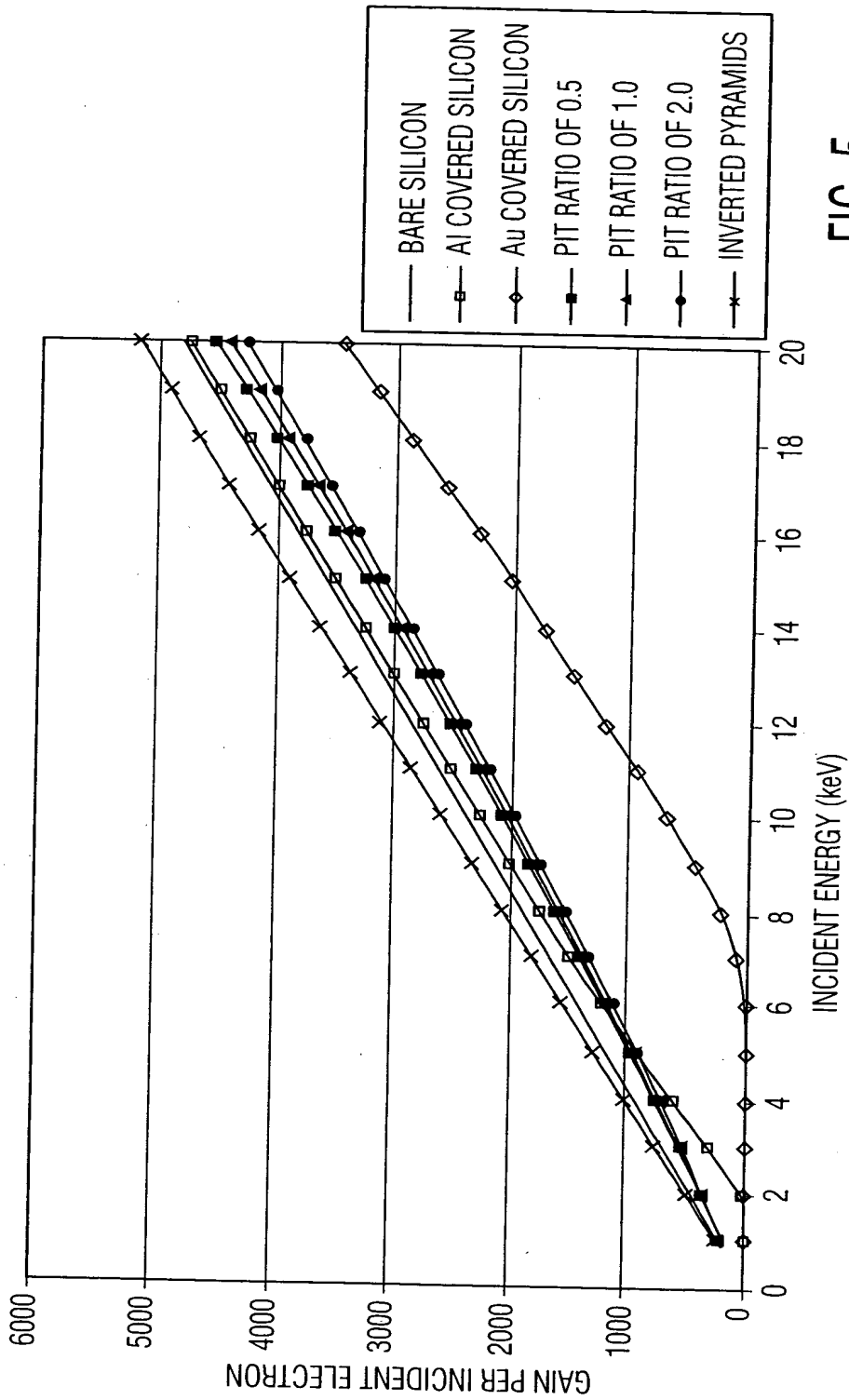
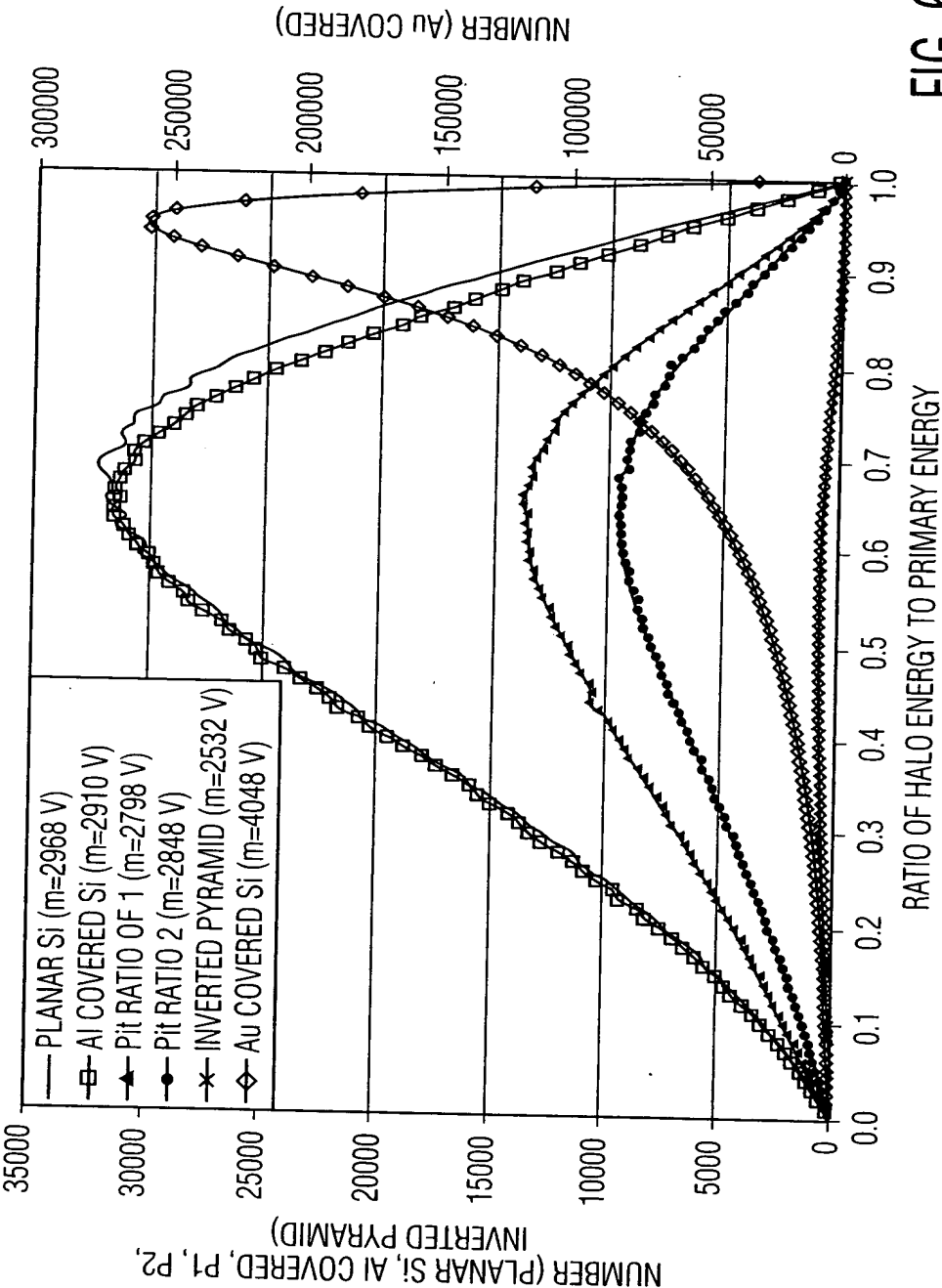


FIG. 5

5/24



6/24

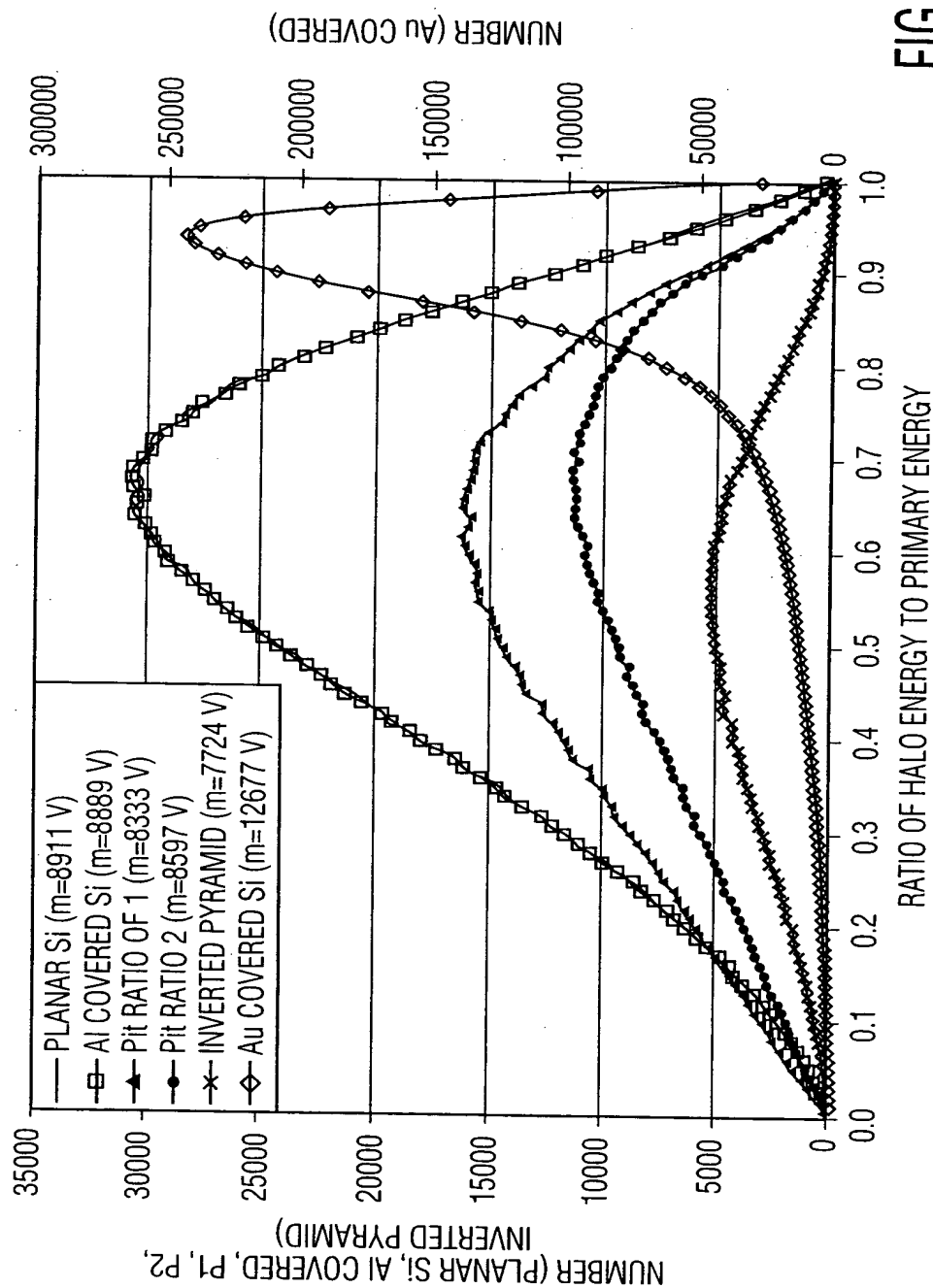


FIG. 6B

7/24

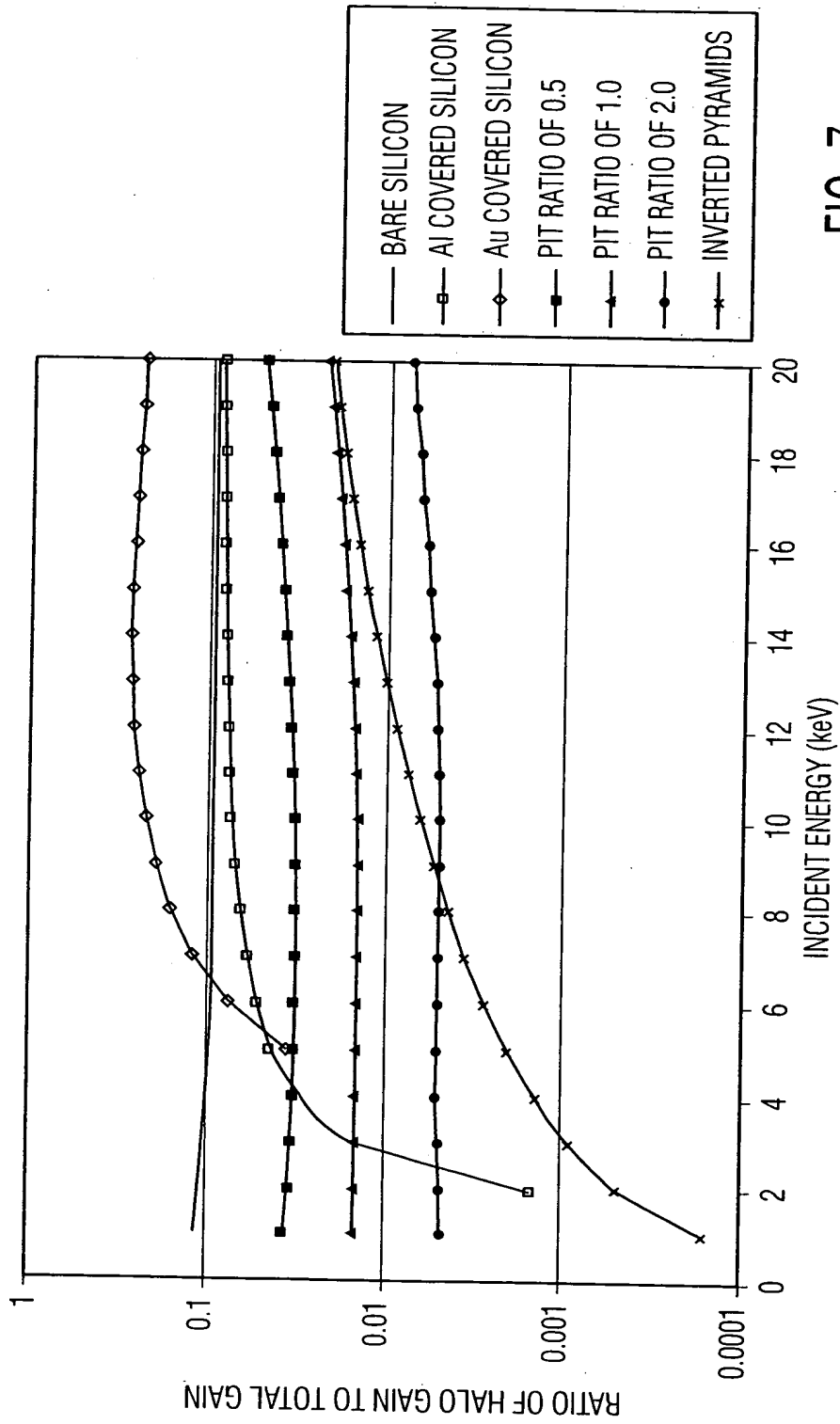
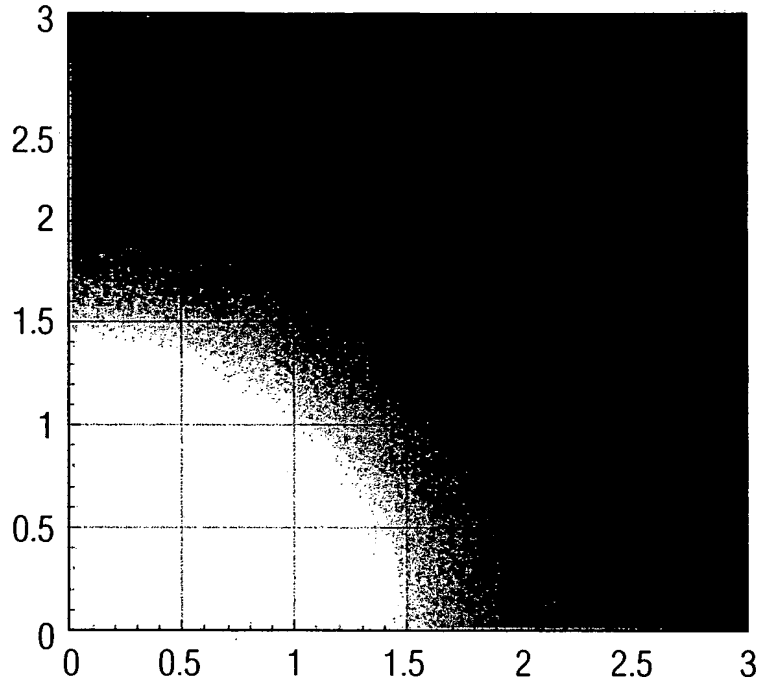


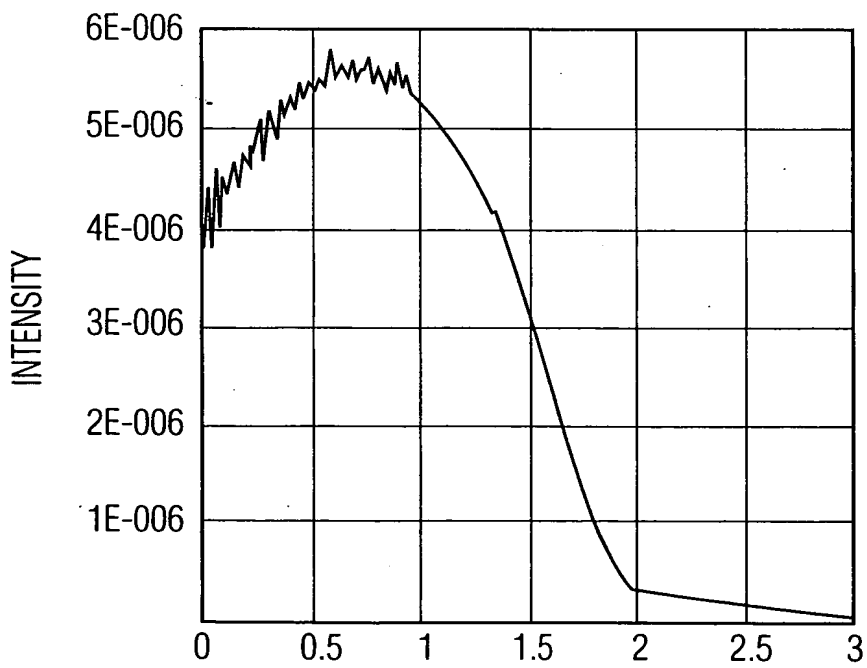
FIG. 7

8/24



PLANAR SILICON

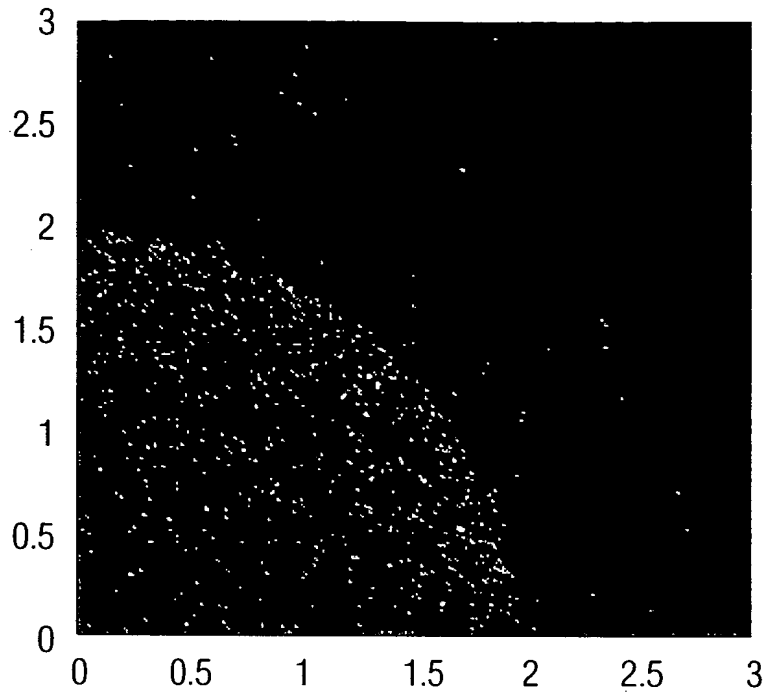
FIG. 8A1



PLANAR SILICON

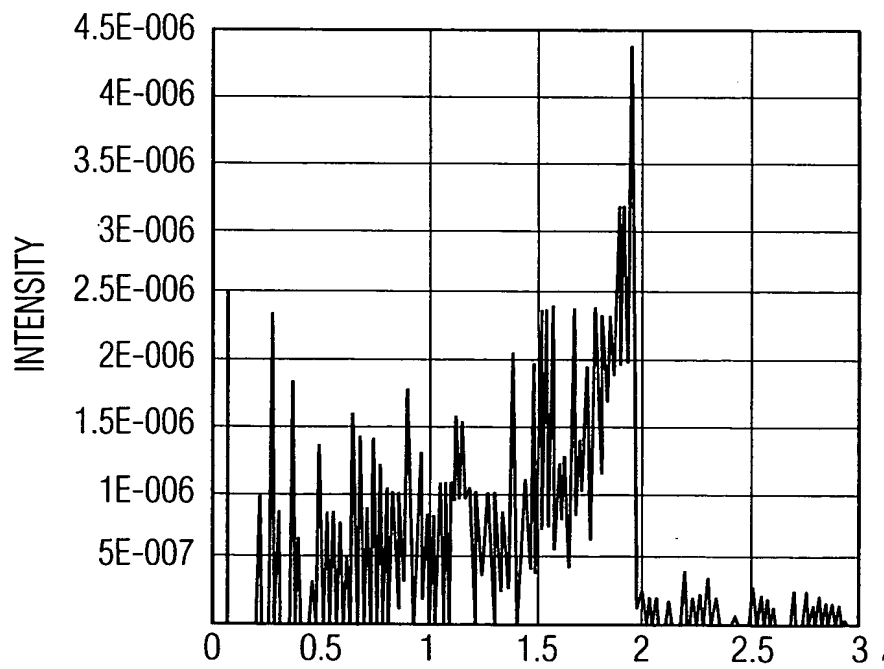
FIG. 8A2

9/24



PLANAR SILICON WITH 500 Å Au OVERCOAT

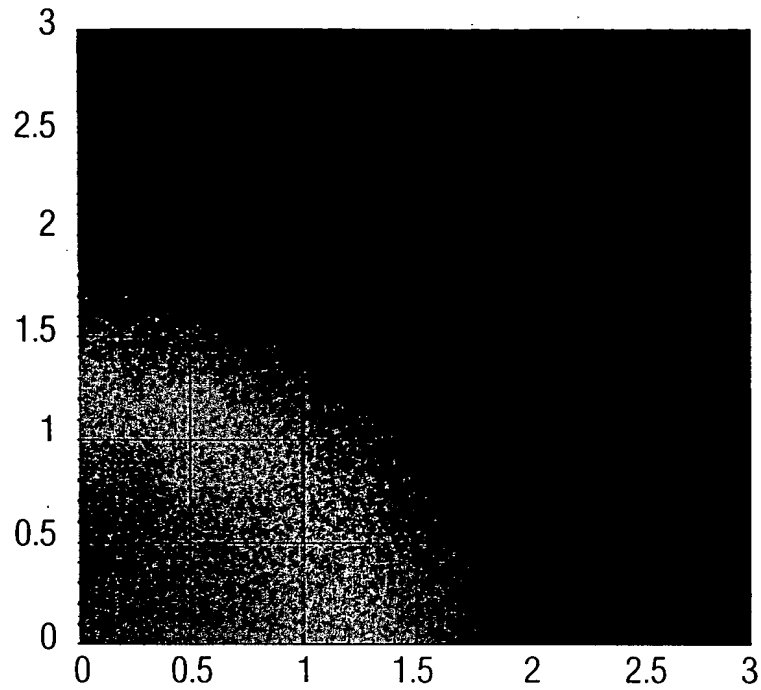
FIG. 8B1



PLANAR SILICON WITH 500 Å Au OVERCOAT

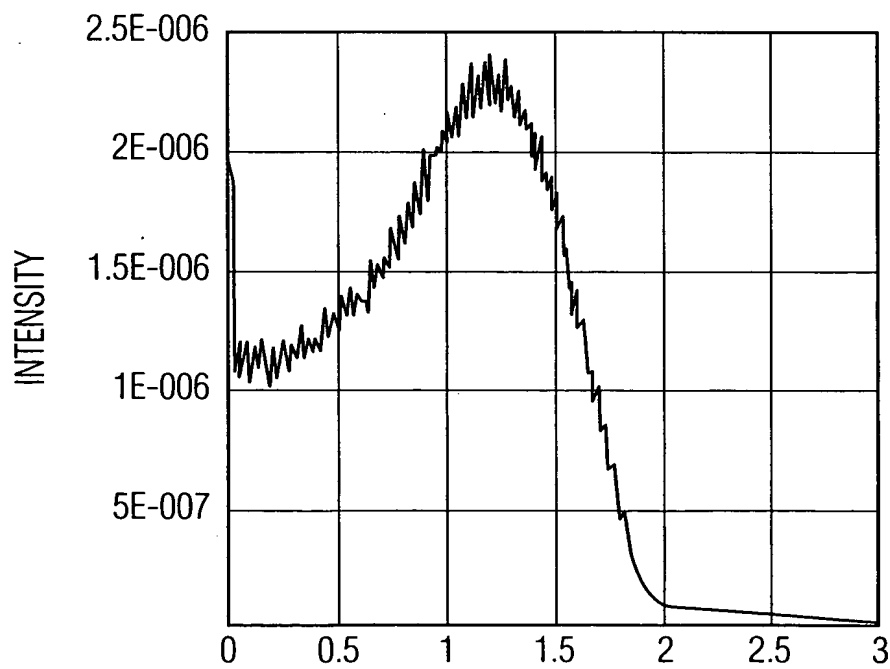
FIG. 8B2

10/24



PLANAR SILICON WITH 500 Å AI OVERCOAT

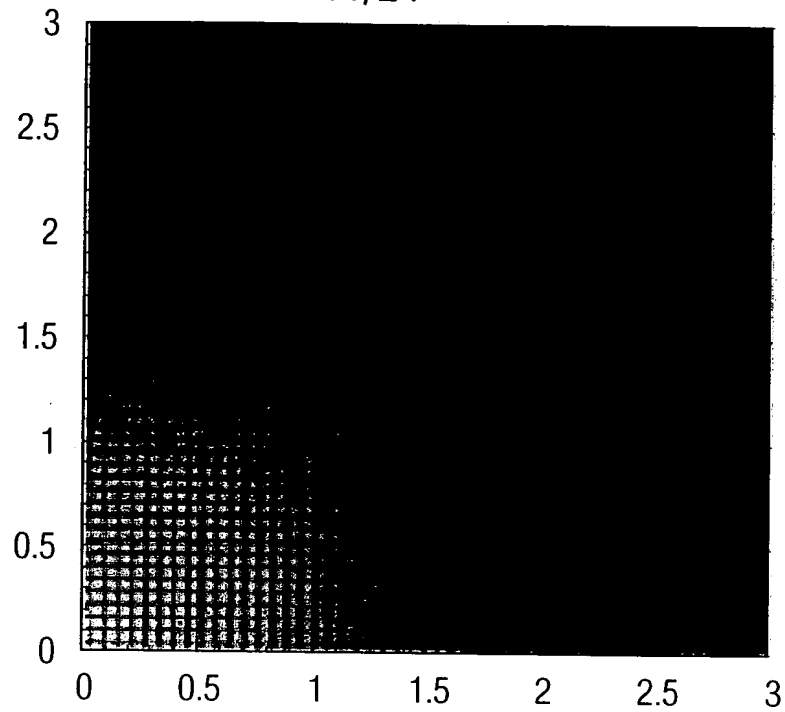
FIG. 8C1



PLANAR SILICON WITH 500 Å AI OVERCOAT

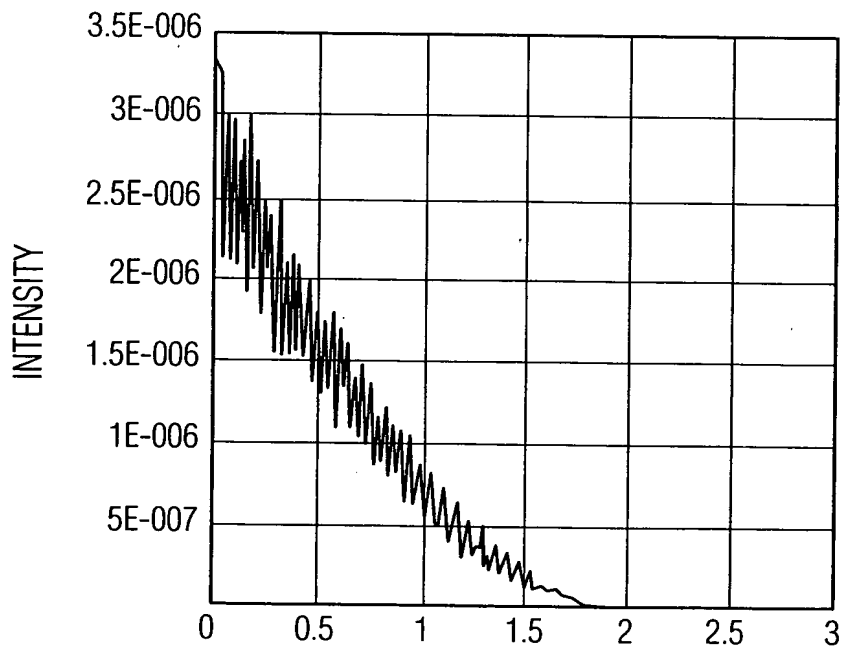
FIG. 8C2

11/24



PIT WITH DEPTH TO PITCH RATIO OF 1 (6 μ m PITCH PIT)

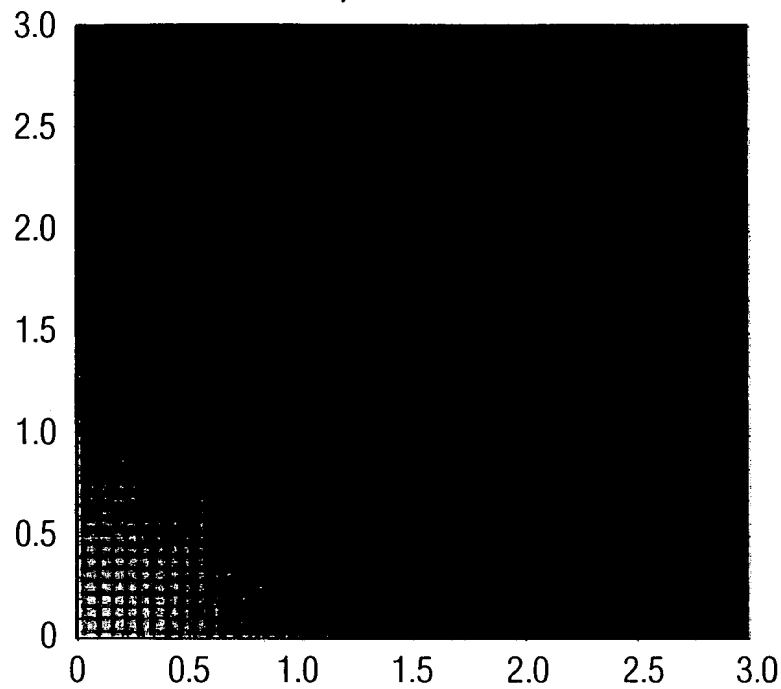
FIG. 8D1



PIT WITH DEPTH TO PITCH RATIO OF 1 (6 μ m PITCH PIT)

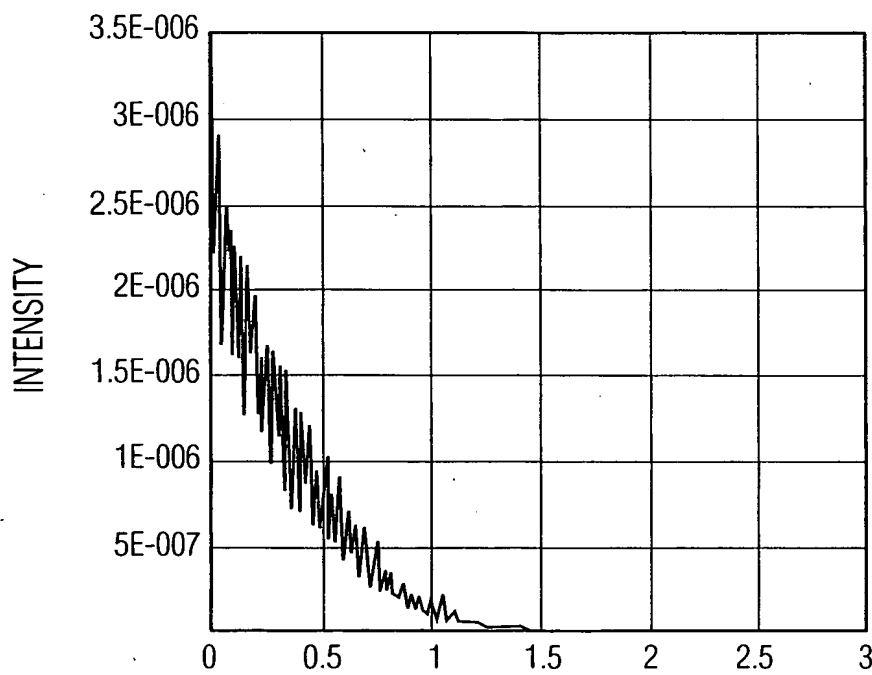
FIG. 8D2

12/24



PIT WITH DEPTH TO PITCH RATIO OF 2 (6 μ m PITCH PIT)

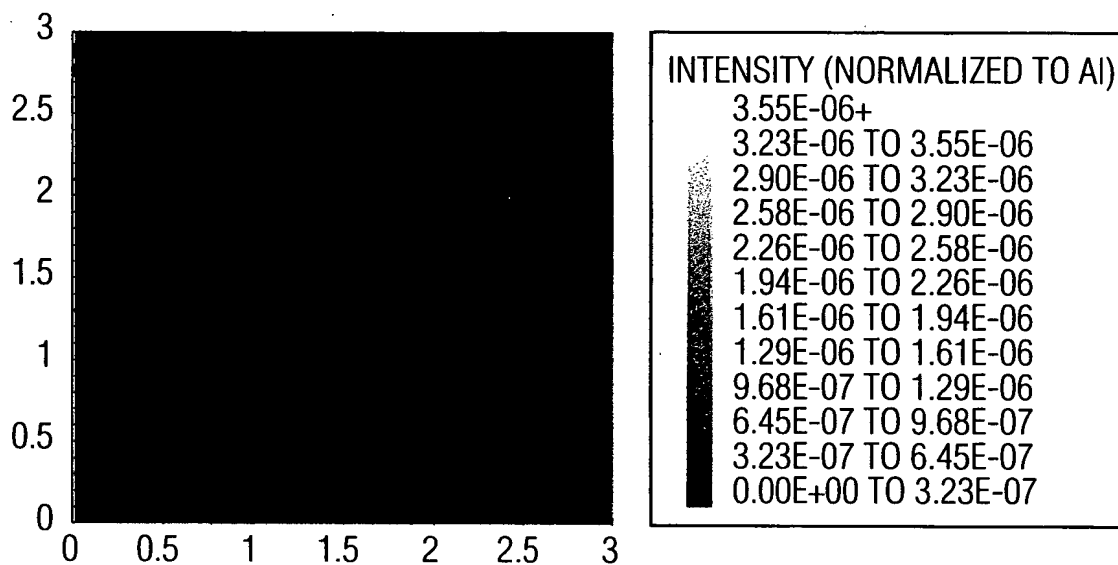
FIG. 8E1



PIT WITH DEPTH TO PITCH RATIO OF 2 (6 μ m PITCH PIT)

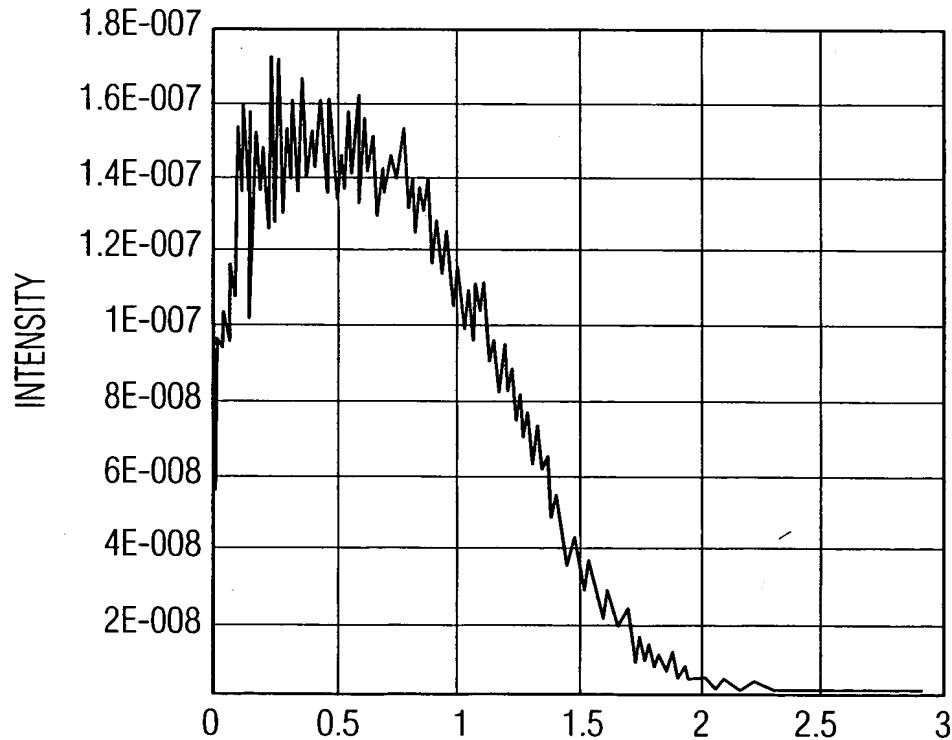
FIG. 8E2

13/24



INVERTED PYRAMID (6 MICRON PITCH)

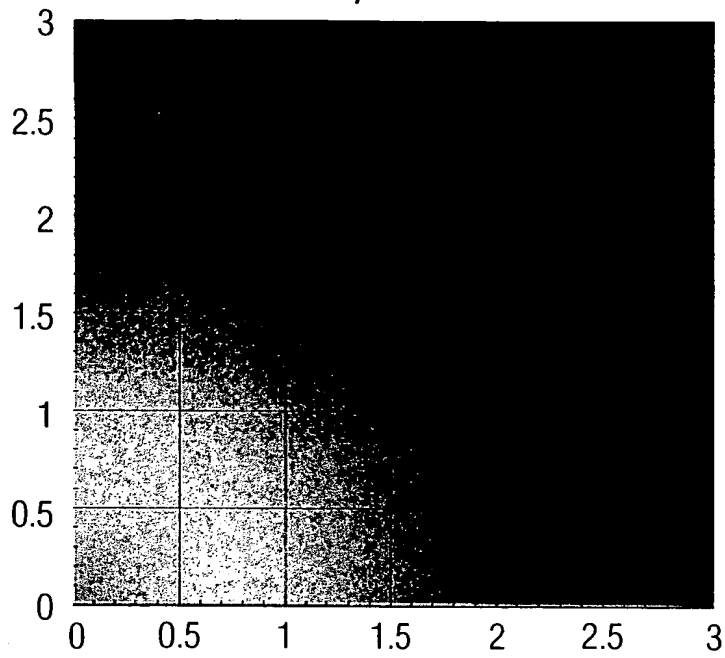
FIG. 8F1



INVERTED PYRAMID (6 MICRON PITCH)

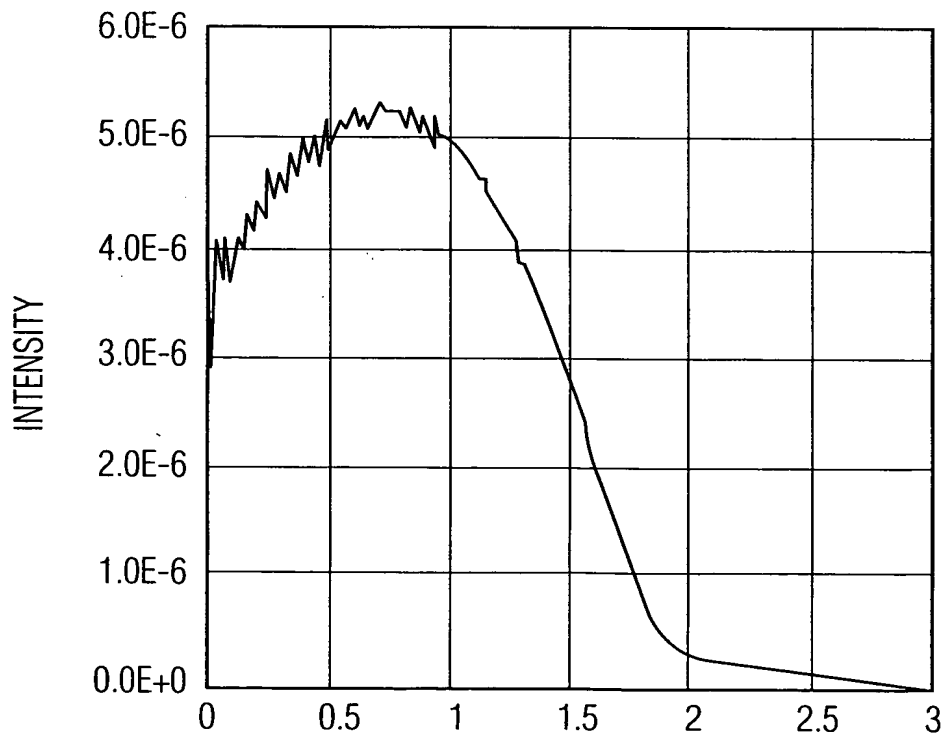
FIG. 8F2

14/24



PLANAR SILICON

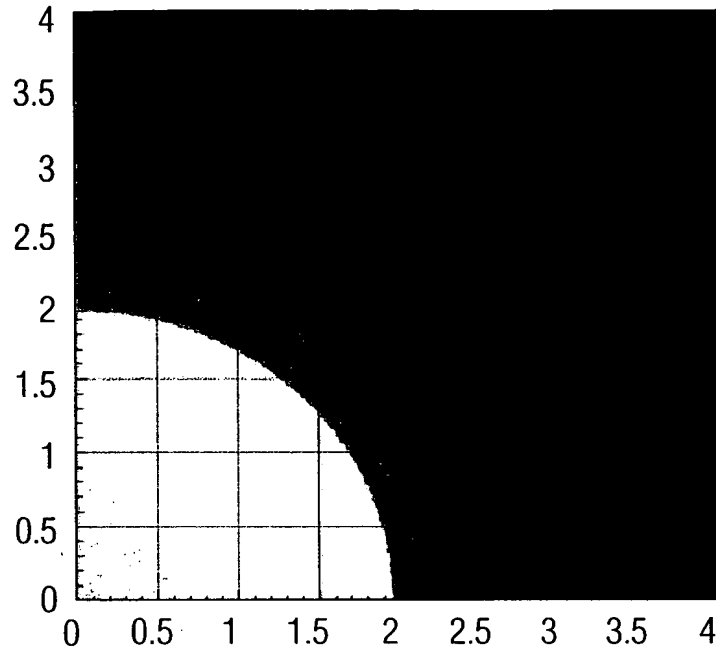
FIG. 9A1



PLANAR SILICON

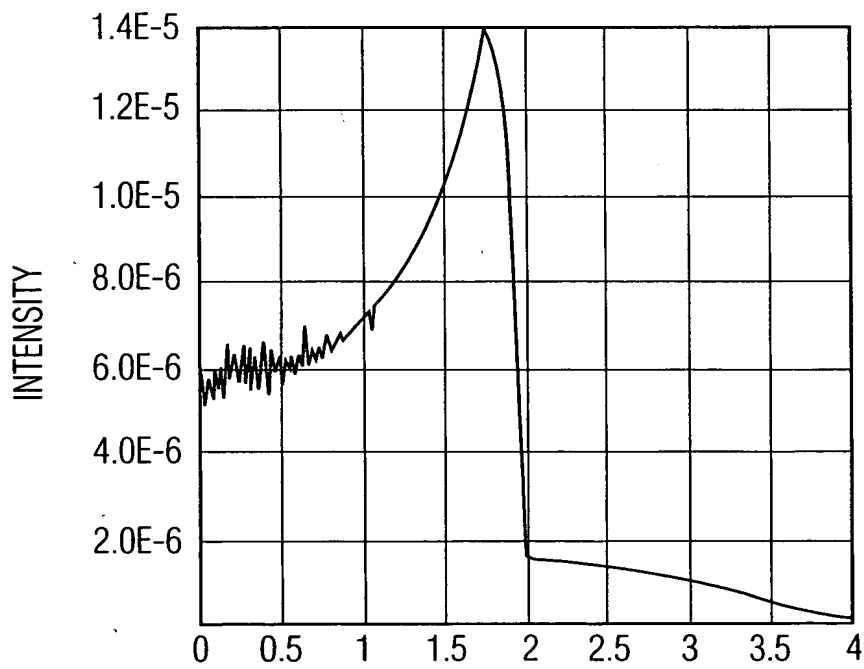
FIG. 9A2

15/24



PLANAR SILICON WITH 500 Å Au

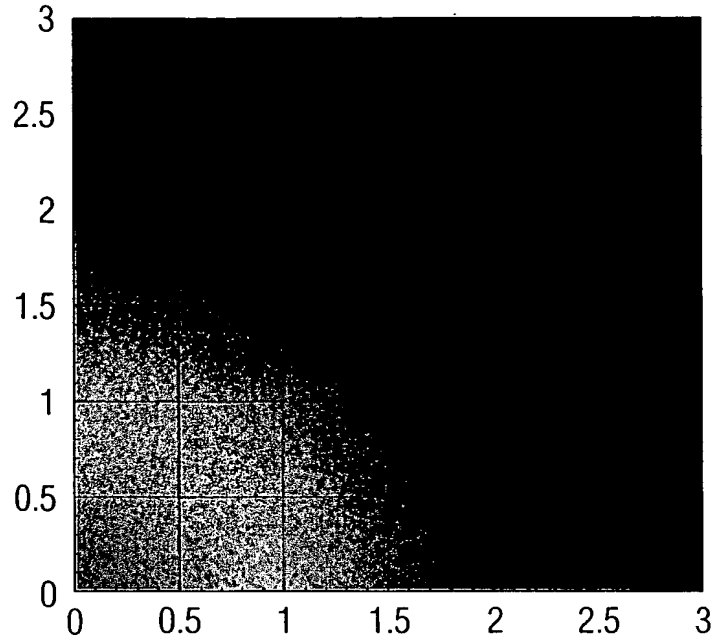
FIG. 9B1



PLANAR SILICON WITH 500 Å Au

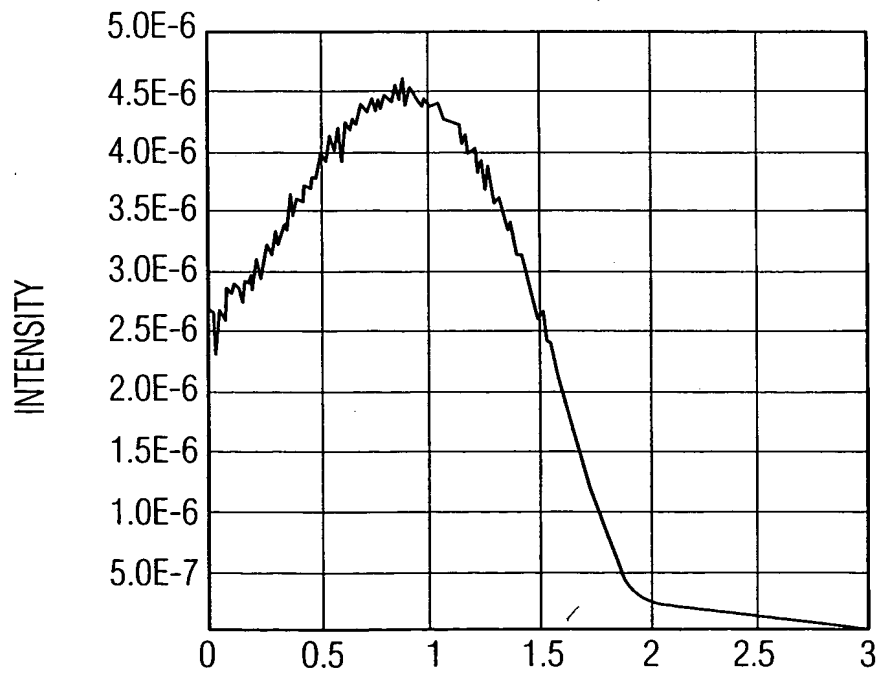
FIG. 9B2

16/24



PLANAR SILICON WITH 500 Å Al

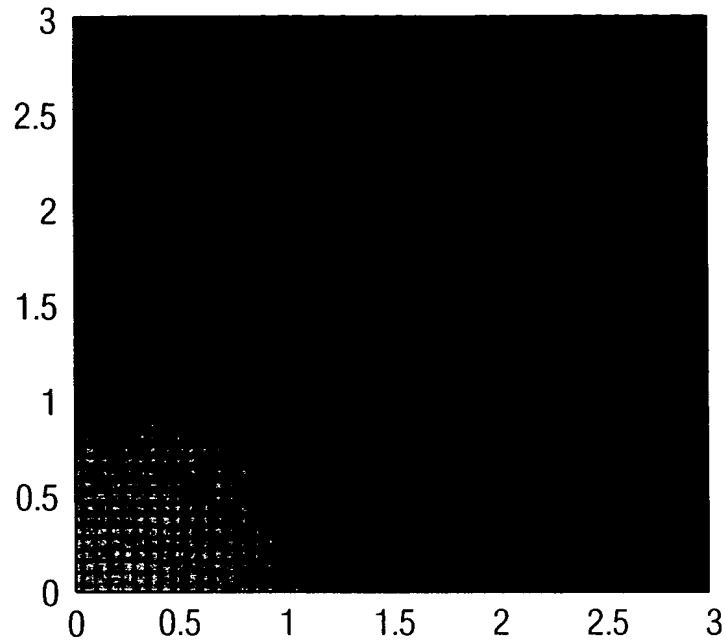
FIG. 9C1



PLANAR SILICON WITH 500 Å Al

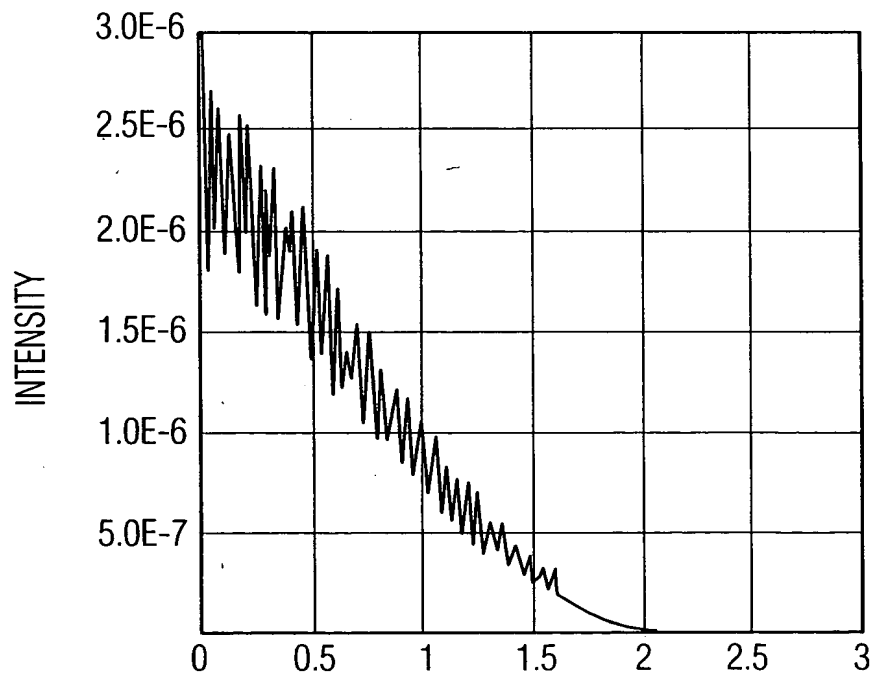
FIG. 9C2

17/24



PIT WITH DEPTH TO PITCH RATIO OF 1

FIG. 9D1



PIT WITH DEPTH TO PITCH RATIO OF 1

FIG. 9D2

18/24

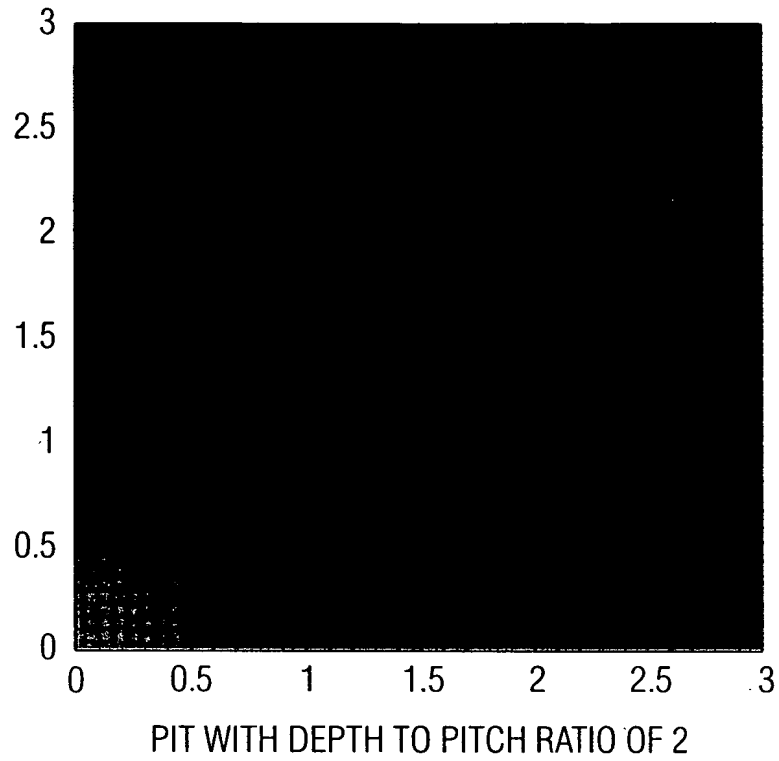


FIG. 9E1

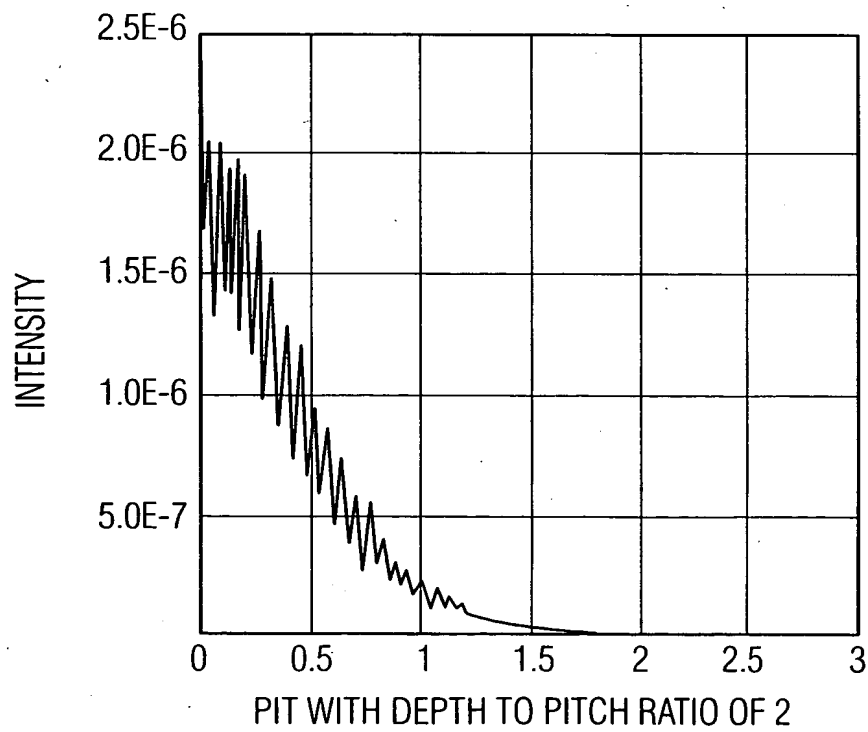
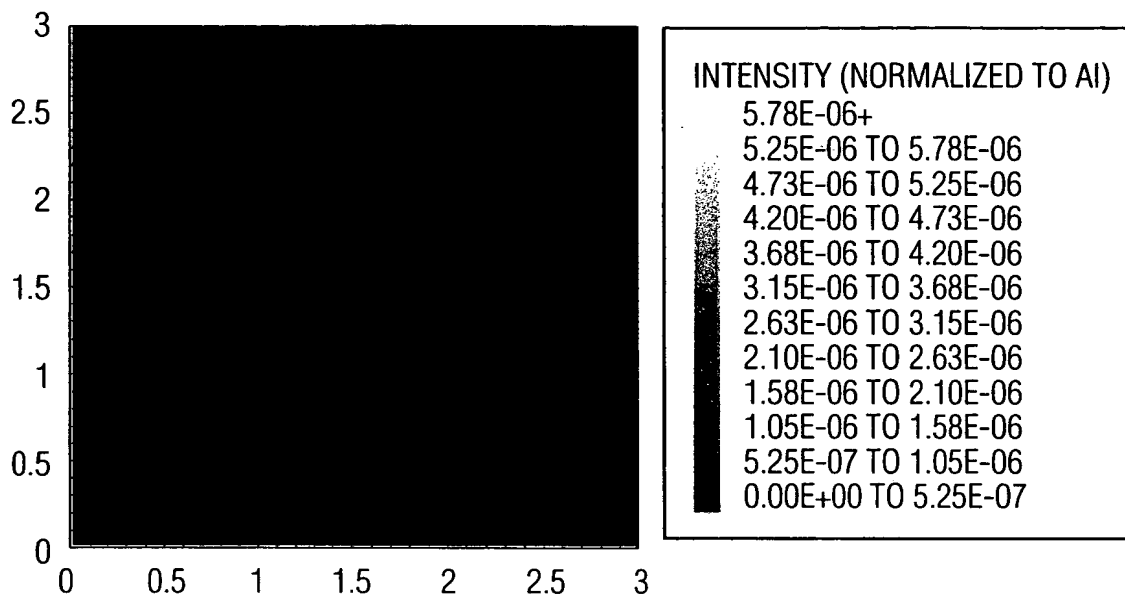


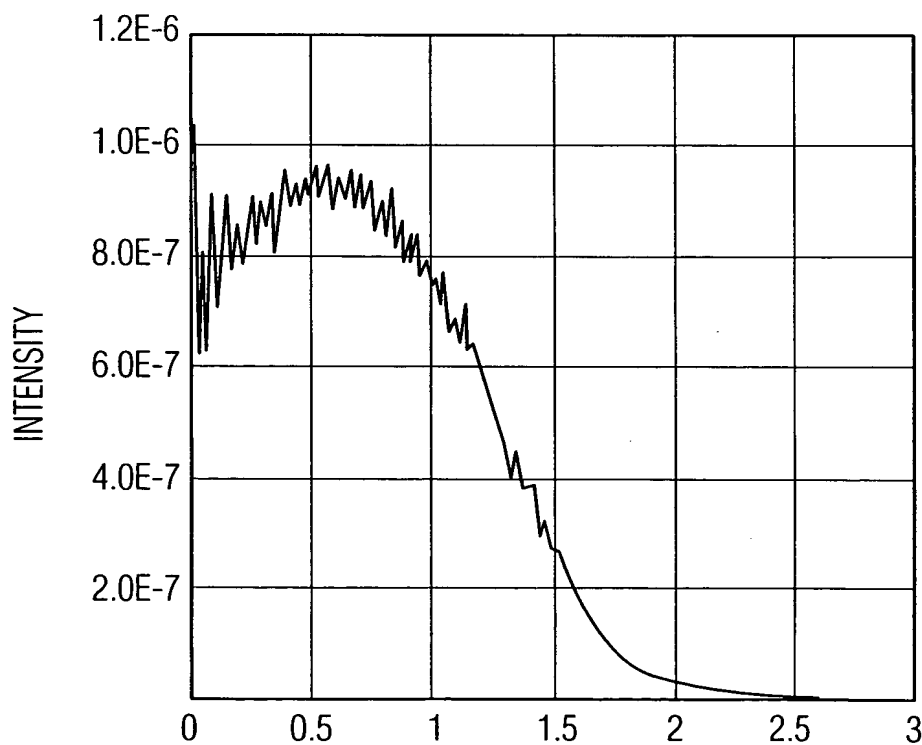
FIG. 9E2

19/24



INVERTED PYRAMIDS

FIG. 9F1



INVERTED PYRAMIDS

FIG. 9F2

20/24

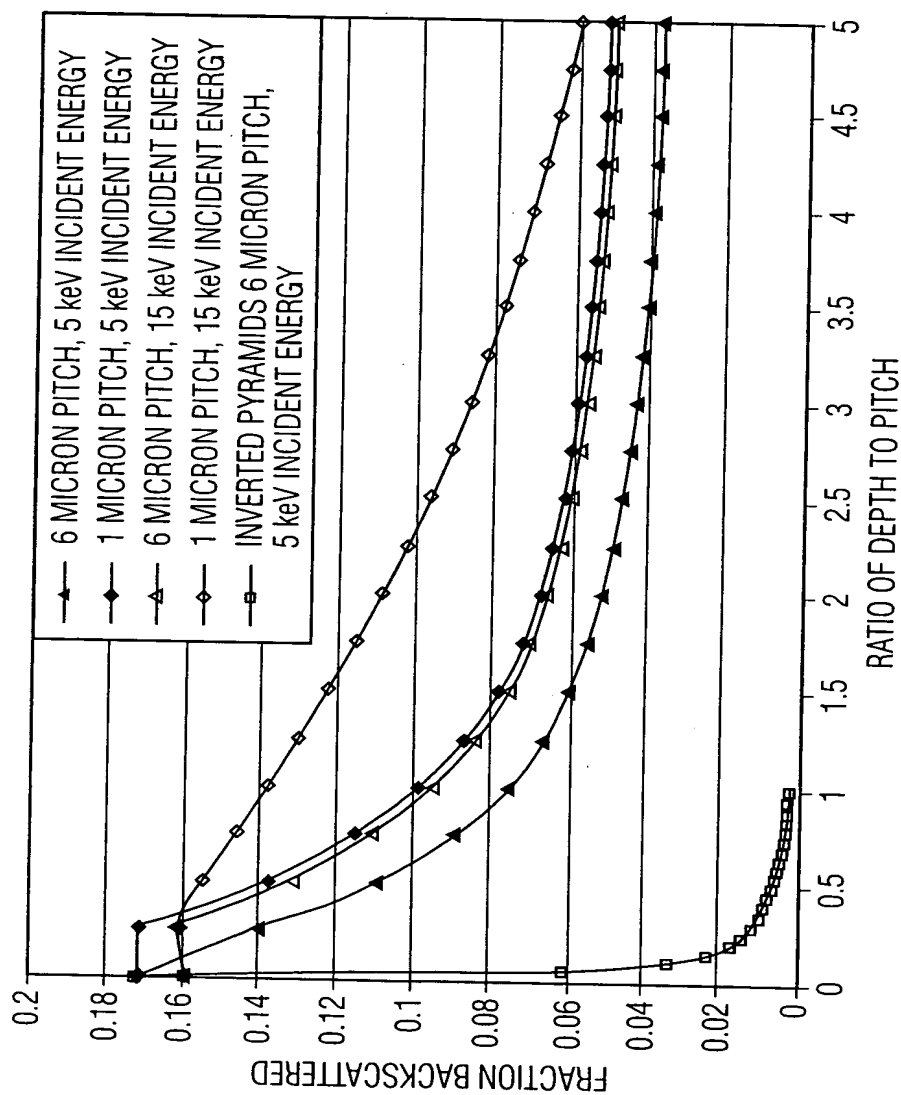


FIG. 10

21/24

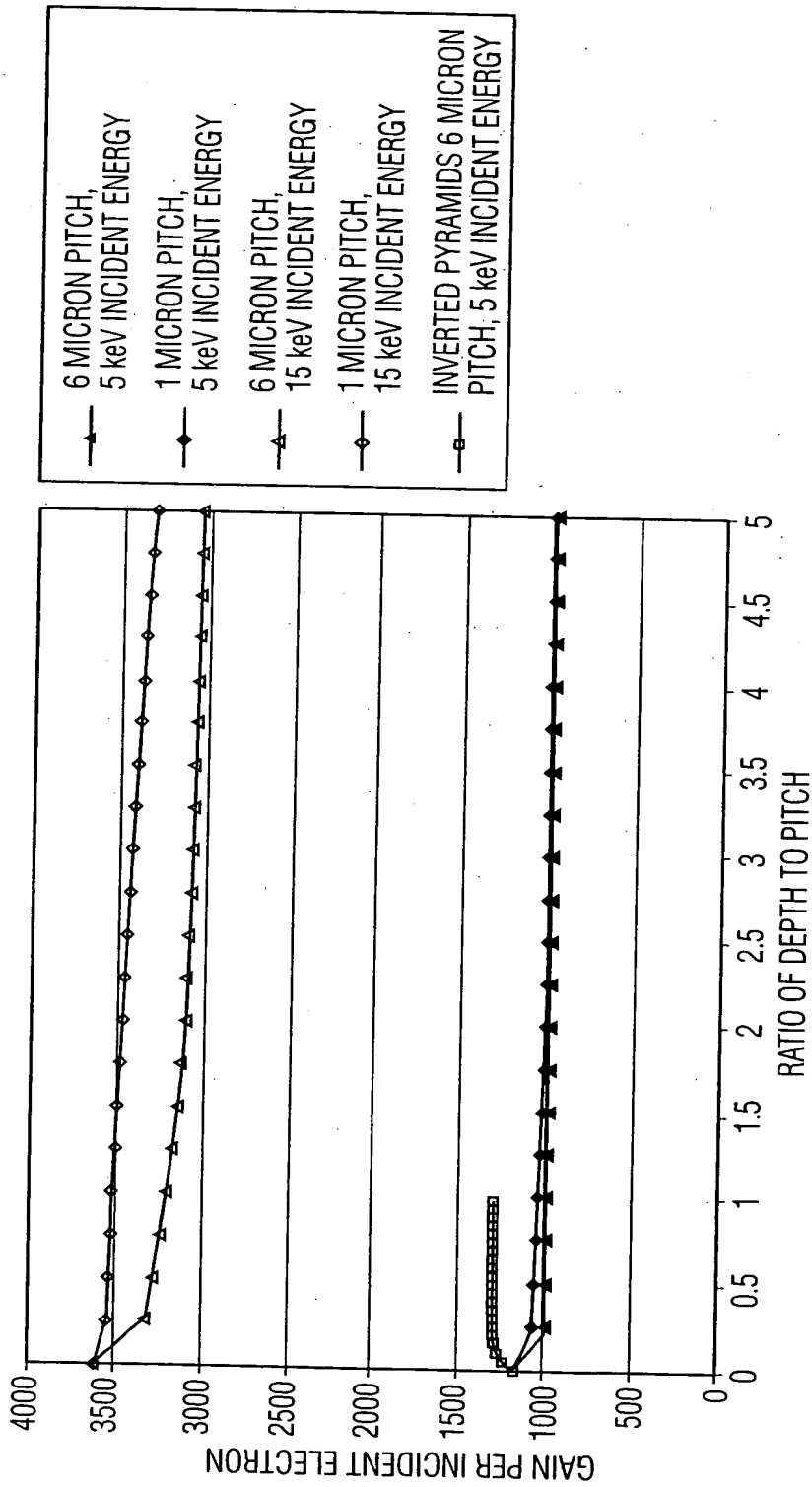


FIG. 11

22/24

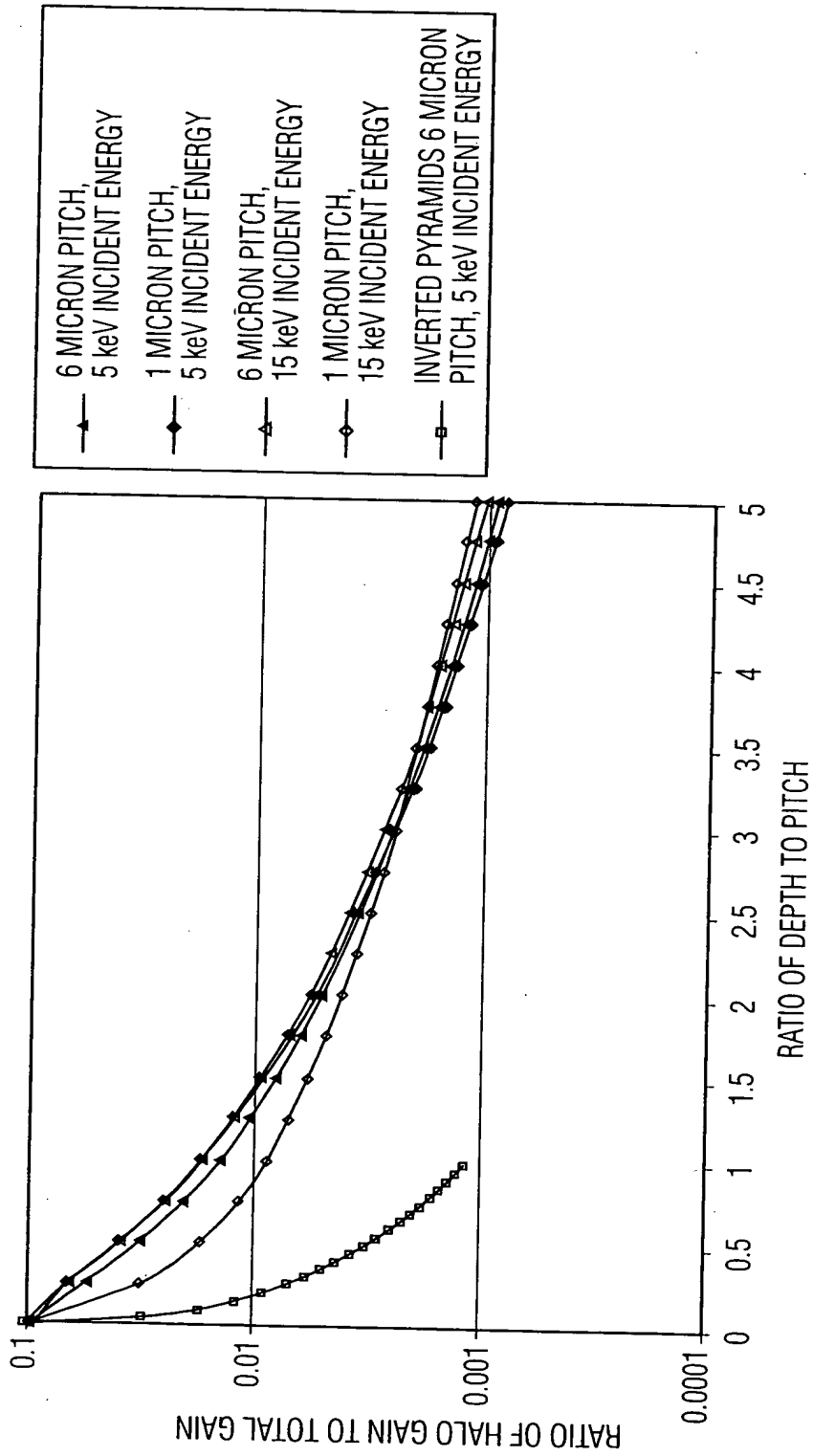
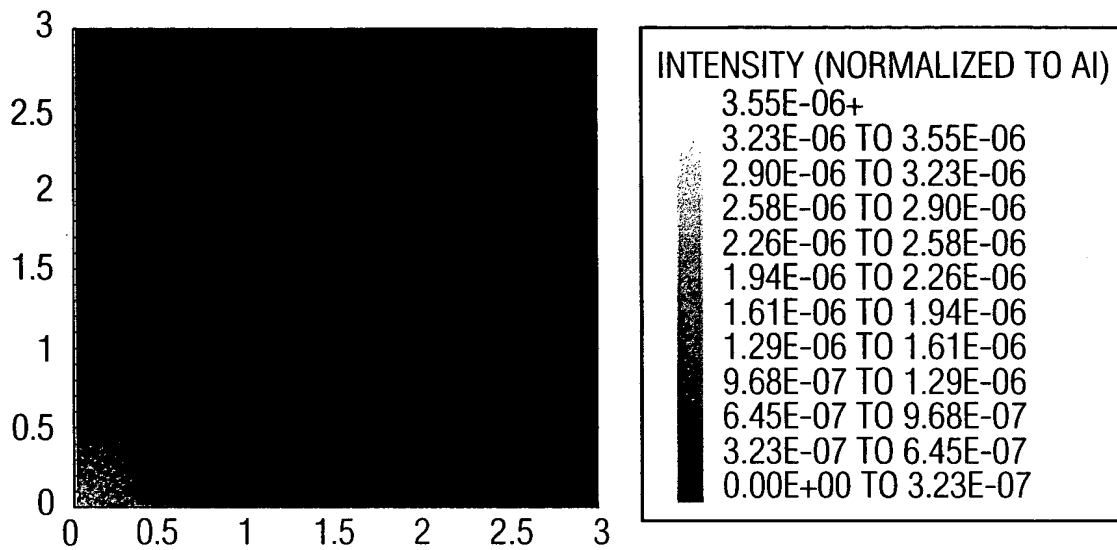


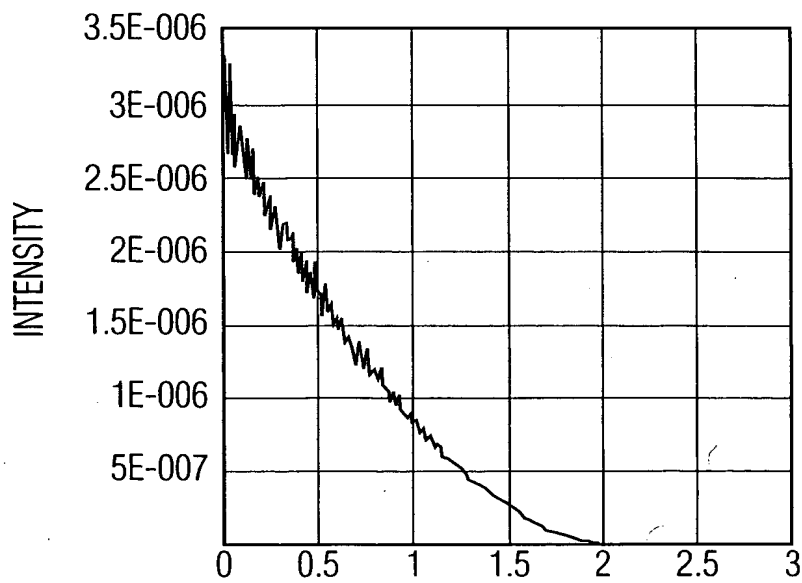
FIG. 12

23/24



1 μ m PITCH PITS, DEPTH TO PITCH RATIO OF 1

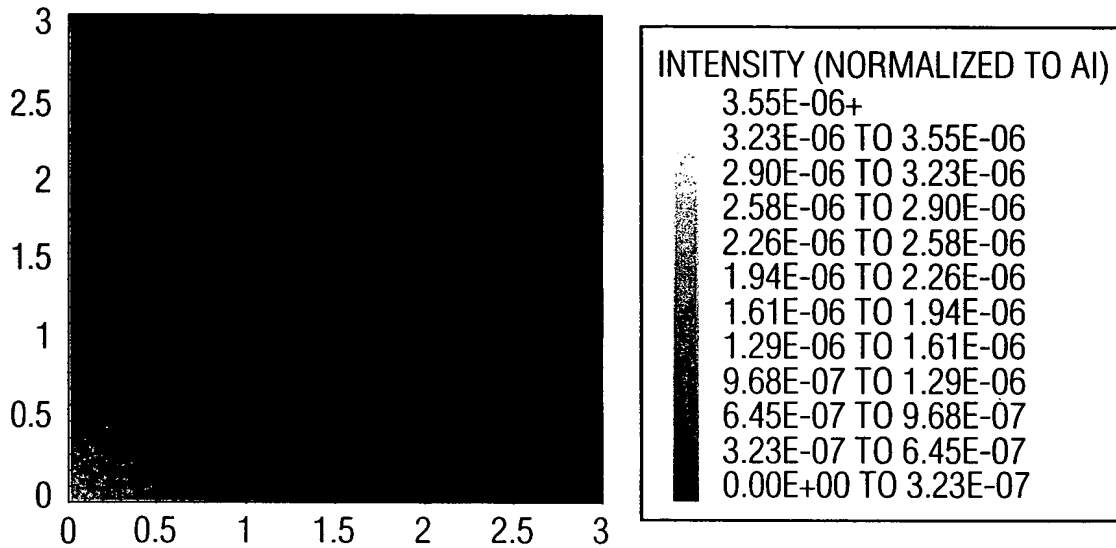
FIG. 13A1



1 μ m PITCH PITS, DEPTH TO PITCH RATIO OF 1

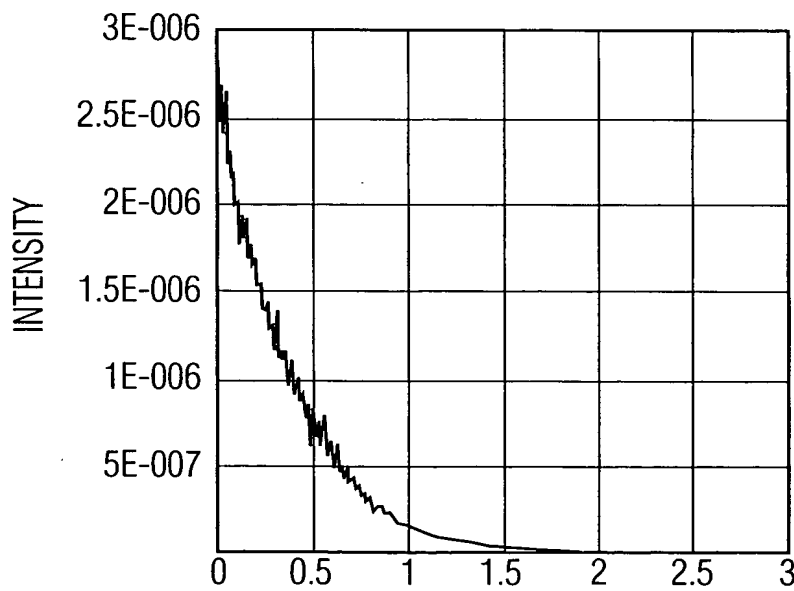
FIG. 13A2

24/24



1 μ m PITCH PITS, DEPTH TO PITCH RATIO OF 2

FIG. 13B1



1 μ m PITCH PITS, DEPTH TO PITCH RATIO OF 2

FIG. 13B2